



"Express Mail" Label No. EY780616376US  
Date of Deposit March 29, 2006

I hereby certify that this is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.116 on the date indicated above and is addressed to:

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

By Anna S. McNeill

**AMENDMENT UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE -  
EXAMINING GROUP 1753**

PATENT

Attorney Docket No.: A8067/T51700  
AMAT No.: 008067/DSM/HDP/CVD/JW  
TTC No.: 016301-051700US

*OK 2 5/9/06  
ENTER BR*  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

*not  
ENTER  
ML 3/14/06*  
In re application of:

Hemant P. Mungekar et al.

Application No.: 10/660,813

Filed: September 12, 2003

For: REACTIVE ION ETCHING FOR  
SEMICONDUCTOR DEVICE  
FEATURE TOPOGRAPHY  
MODIFICATION

Customer No.: 57385

Confirmation No. 7055

Examiner: McDonald, Rodney Glenn

Technology Center/Art Unit: 1753

**AMENDMENT UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE EXAMINING  
GROUP 1753**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed February 14, 2006 on the above-referenced application, please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 7 of this paper.